

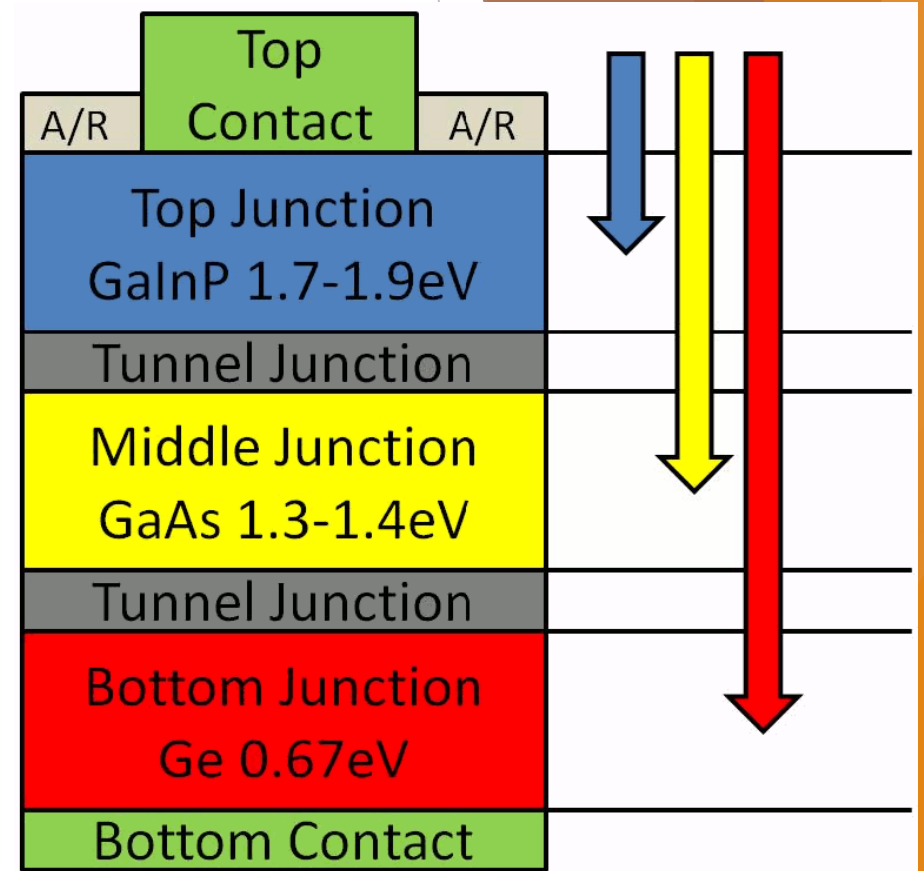
# GalnNAs for Space Applications

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# Multi Junction Solar Cells

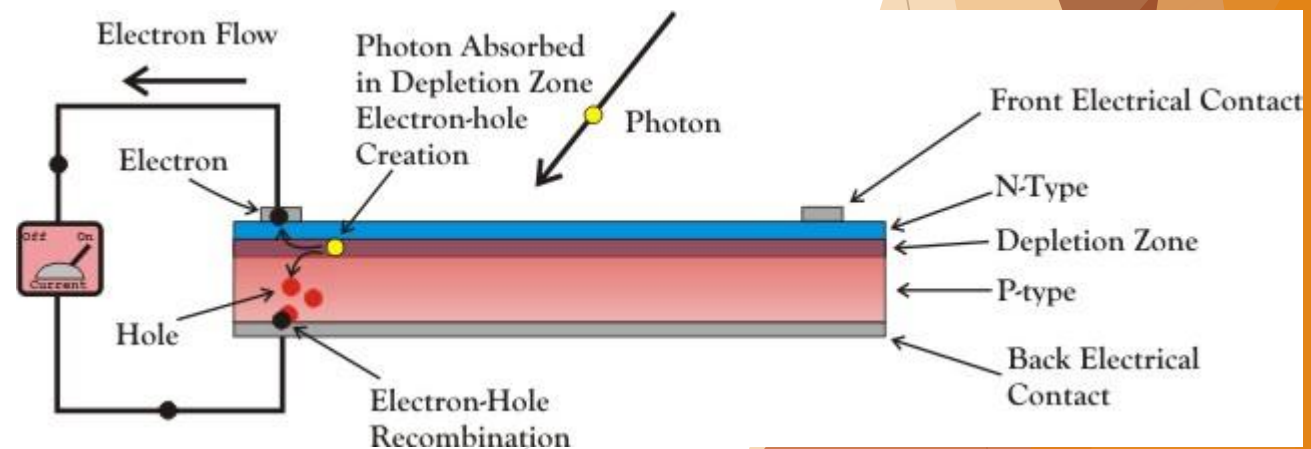
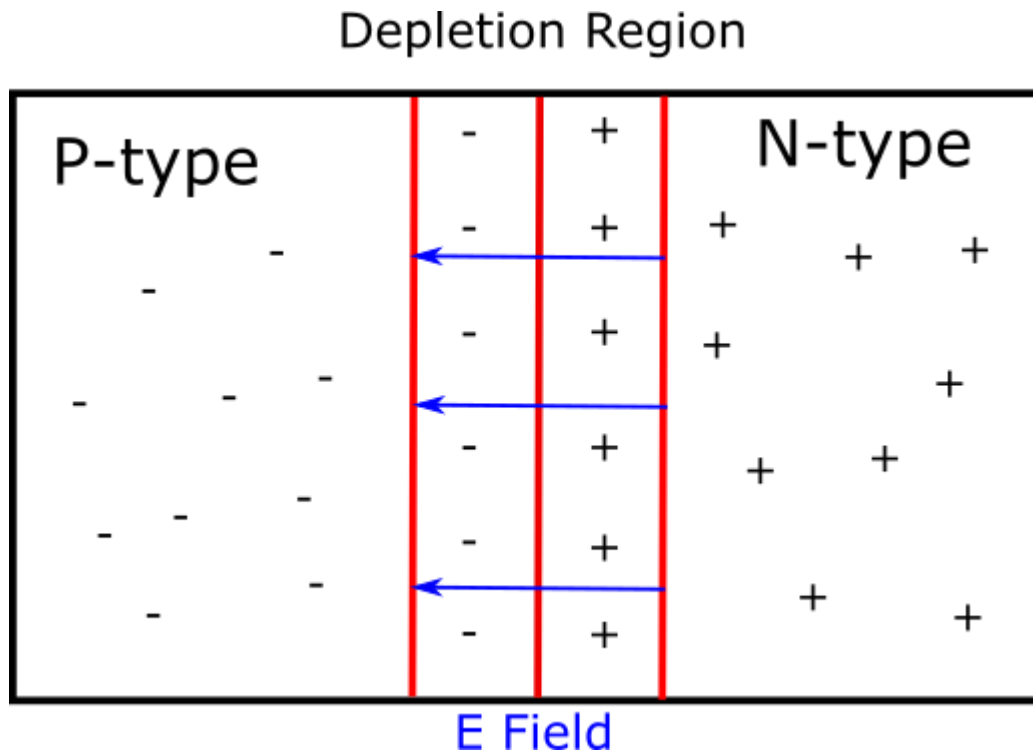
- ▶ Predominantly used in space applications
- ▶ Use multiple cells in series to absorb more light
- ▶ Each additional cell raises the overall efficiency



<http://large.stanford.edu/courses/2010/ph240/weisse2/>

# Solar Cells - P-N Junction

- ▶ Cells work based on P-N Junction, same as a diode
- ▶ Carriers are created in the depletion region
- ▶ Electric field of depletion region collects carriers



# Why GaInNAs?

- ▶ This material, known as dilute nitrides, have usable properties
- ▶ Can be grown on GaAs and lattice matched
- ▶ Can have band gap of 1.0 eV
- ▶ Could allow for a fourth junction in MJSC's

# Previous Work on GaInNAs

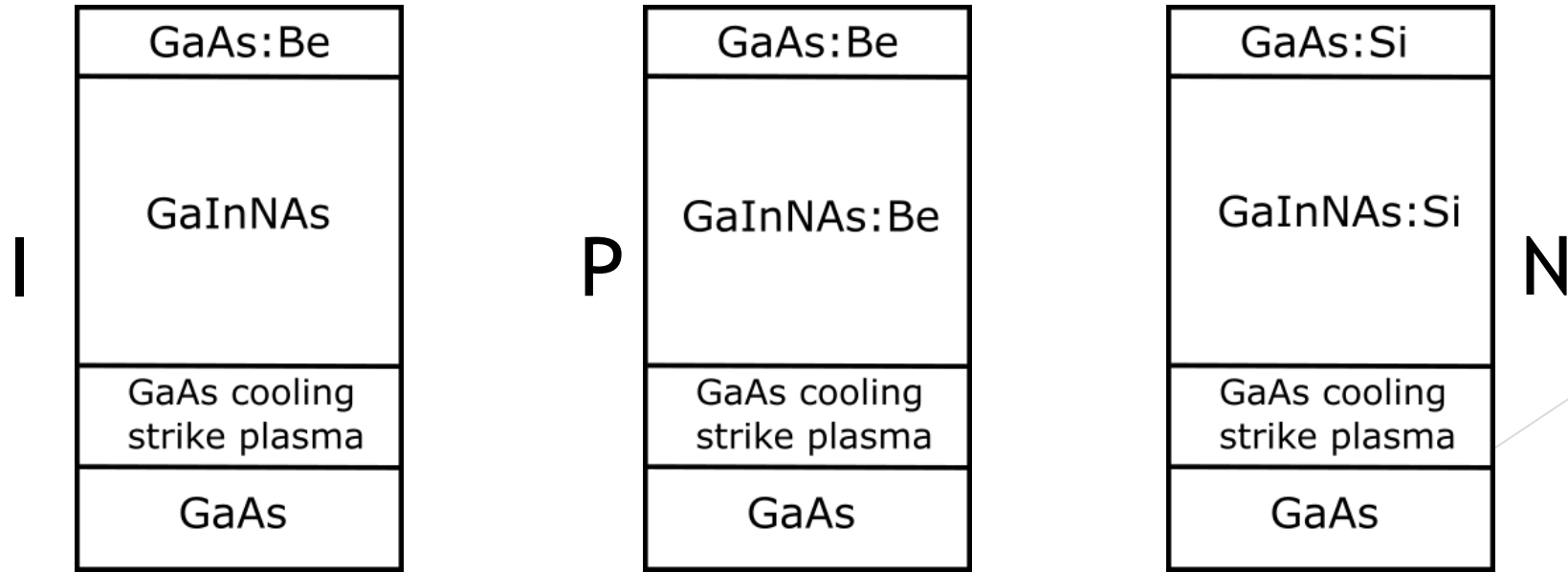
- ▶ The Photovoltaic Materials Research group previously found
  - ▶ GaInNAs has many defects that inhibit its ability to be used
  - ▶ Adding hydrogen into the lattice passivates defects
- ▶ This passivation has shown increased performance in solar cells
- ▶ But how does hydrogenation affect electrical properties?

# Samples

- ▶ Three samples were tested
  - ▶ One intrinsic, n-type, p-type
- ▶ N-type GaInNAs doped with Si
  - ▶ N-type means majority carriers are electrons
- ▶ P-type GaInNAs doped with Be
  - ▶ P-type means majority carriers are holes

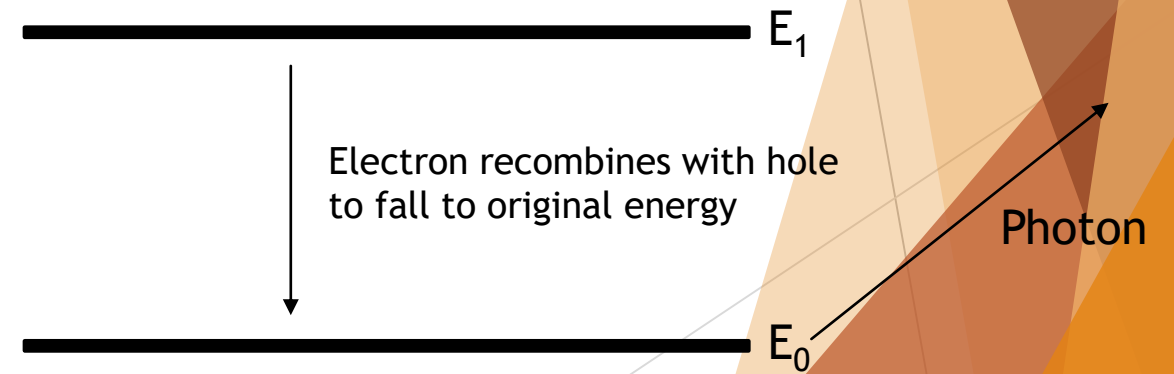
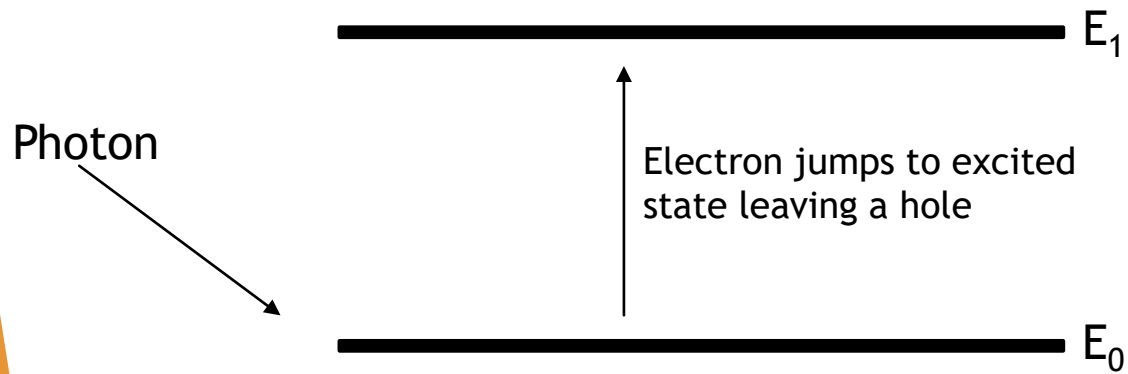
# Structure

- ▶ All grown in 1  $\mu\text{m}$  thick GaAs substrate
- ▶ Followed by a 200 nm thick GaAs cooling strike plasma
- ▶ Followed by a 2  $\mu\text{m}$  thick GaInNAs layer
  - ▶ n-type GaInNAs:Si
  - ▶ p-type GaInNAs:Be
- ▶ Intrinsic and p-type terminated with GaAs:Be cap
- ▶ n-type terminated with GaAs:Si cap



# Experimental Techniques - Photoluminescence

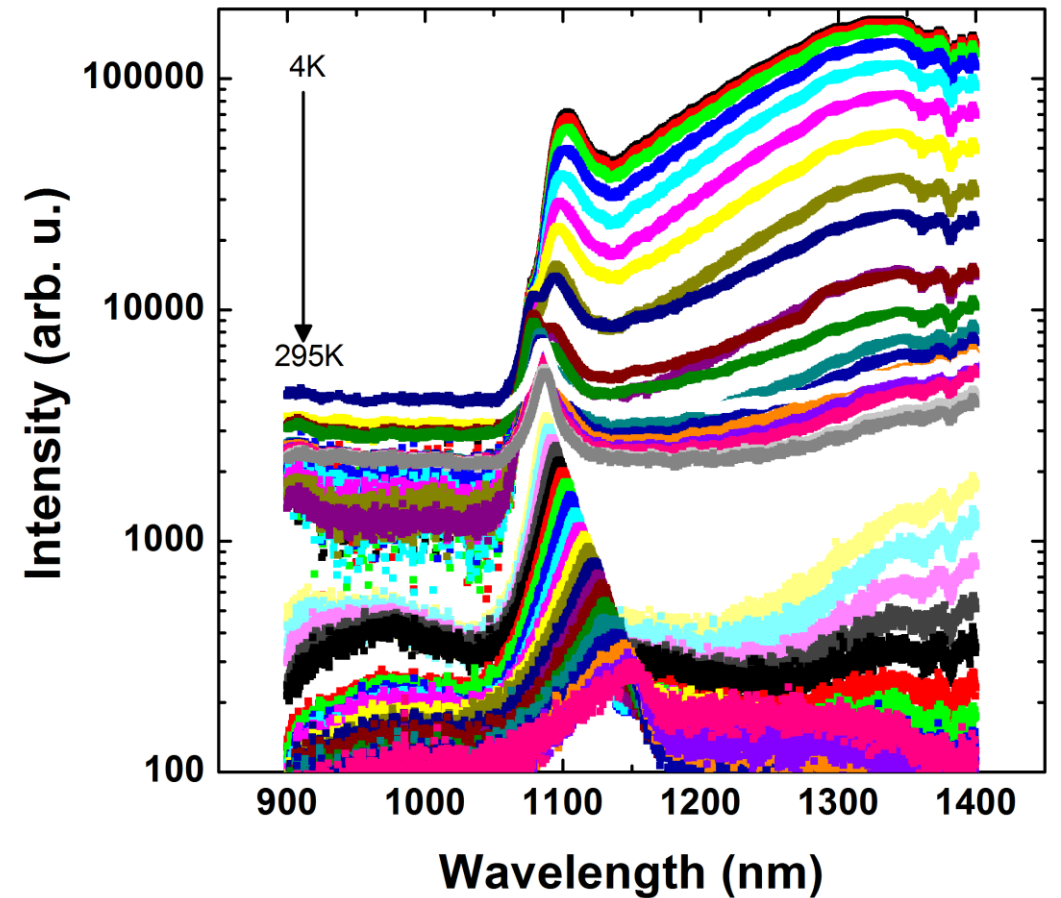
- ▶ Spectroscopic technique used to investigate defects
- ▶ Shine a laser onto sample to create carriers
- ▶ Carriers recombine and then emit a photons
- ▶ Analyze the resulting spectra





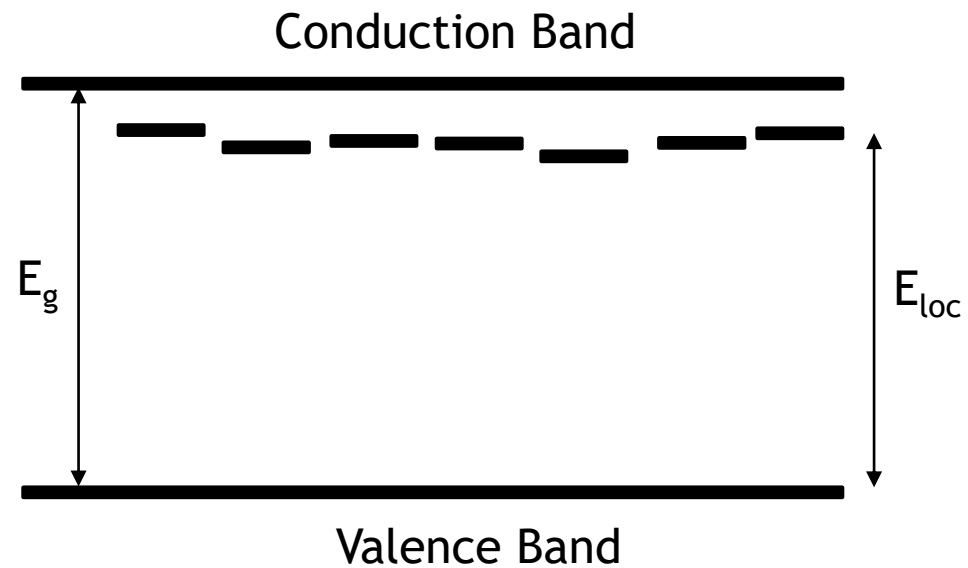
# Intrinsic - PL

- ▶ Large defect band, dominates at low temperature
- ▶ Carrier localization at low temperature
- ▶ Peak dominance shifts at 40 K- 45 K



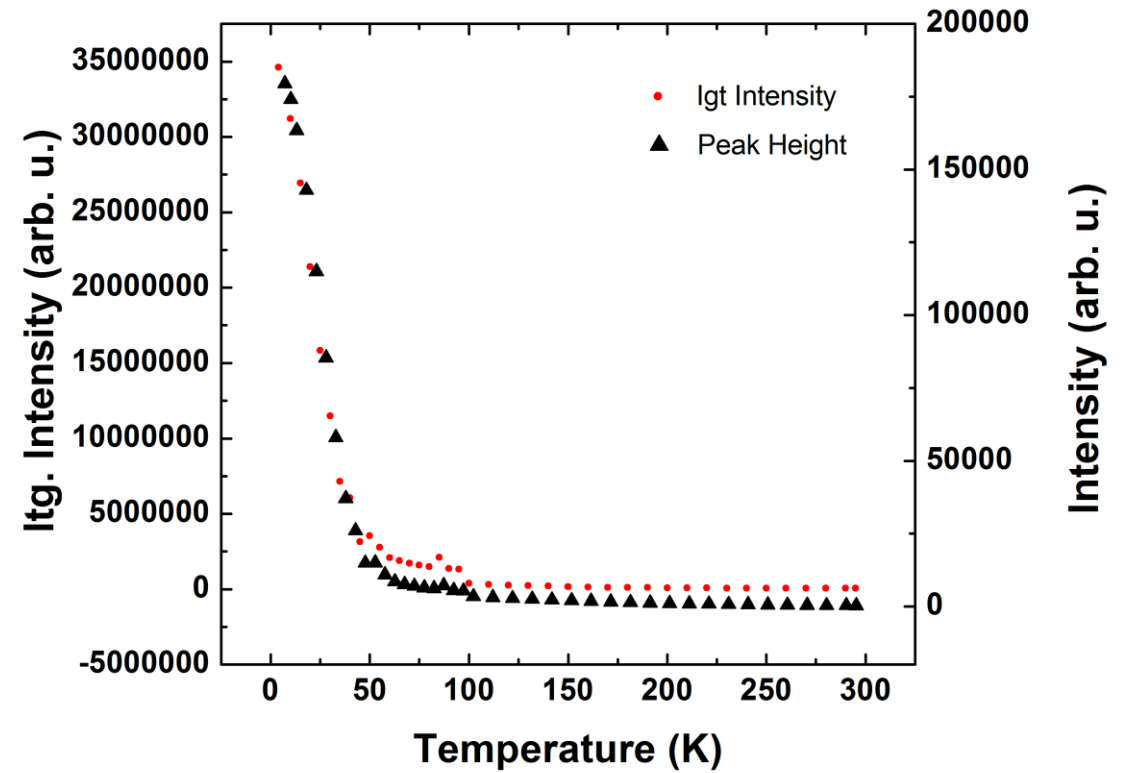
# Localized States

- ▶ How does this spectra indicate localized states?
- ▶ States near band gap due to growth defects



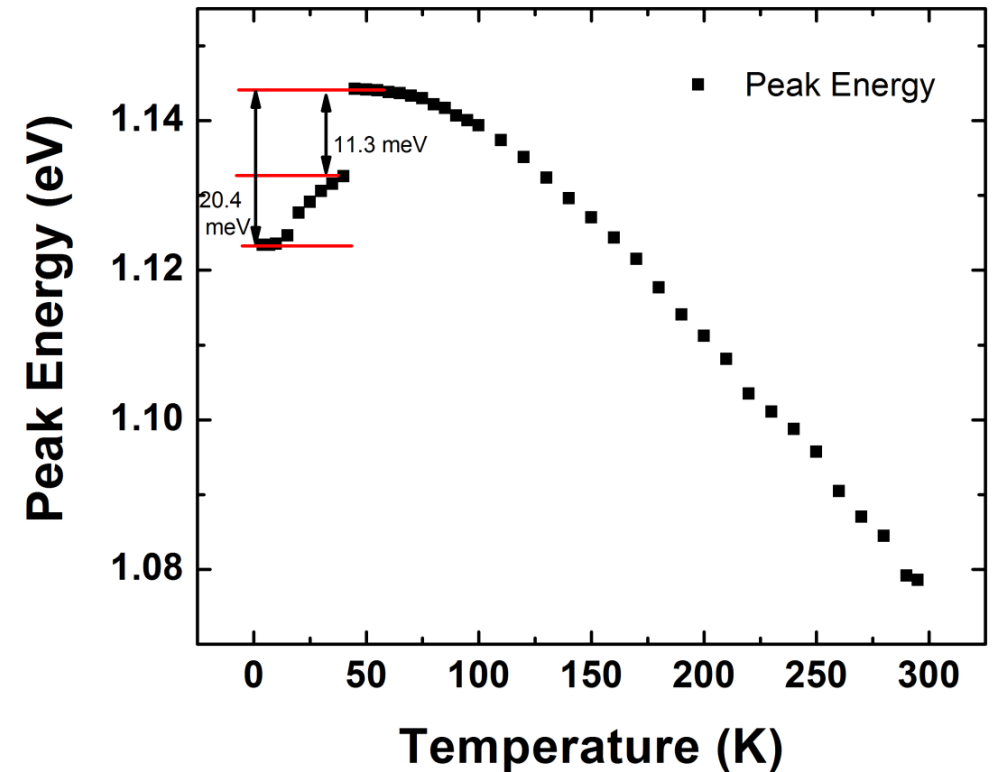
# Intrinsic - PL

- ▶ Carrier localization at low temperature
- ▶ Peak dominance shifts at 45K
- ▶ Large quench in intensity, reflects carrier diffusion



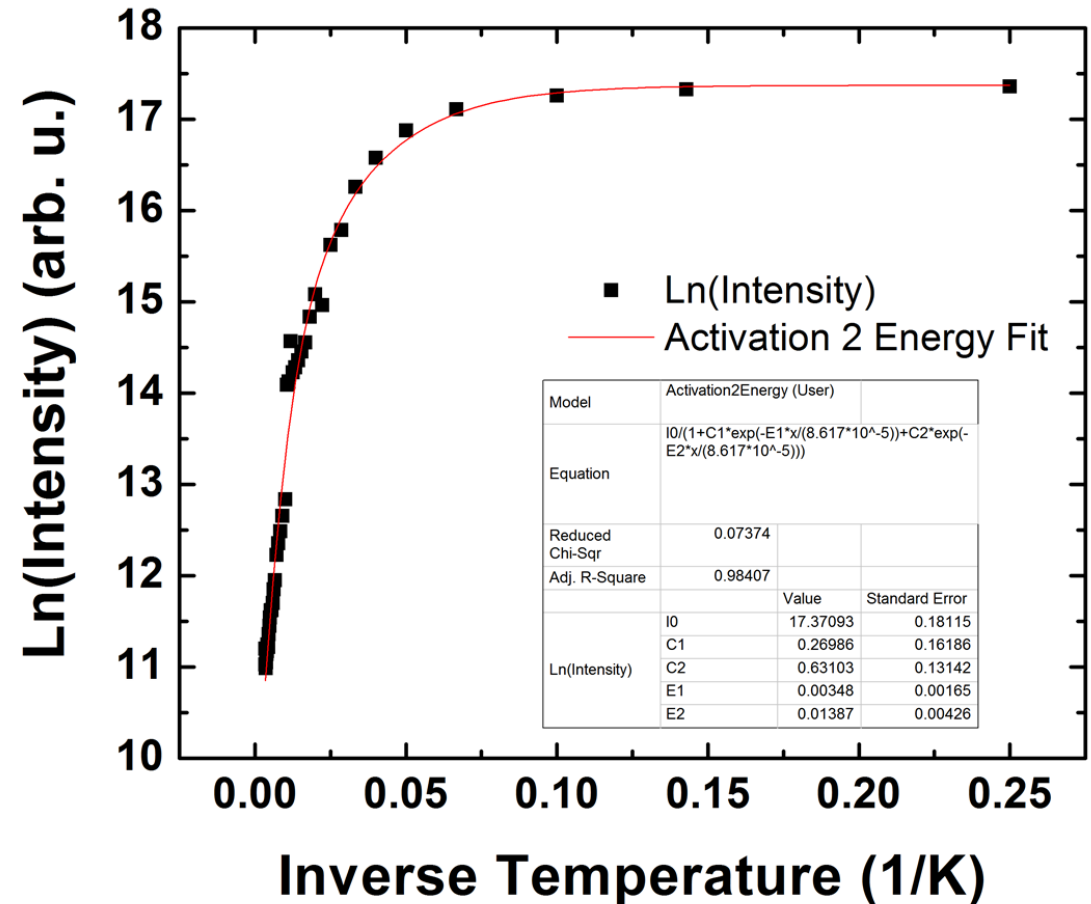
# Intrinsic - Peak Energy

- ▶ Has S-shape with temperature
- ▶ Shift occurs at 45K, reflects the change in peak dominance at 45K
- ▶ Shows the typical band gap dependence with temperature after shift



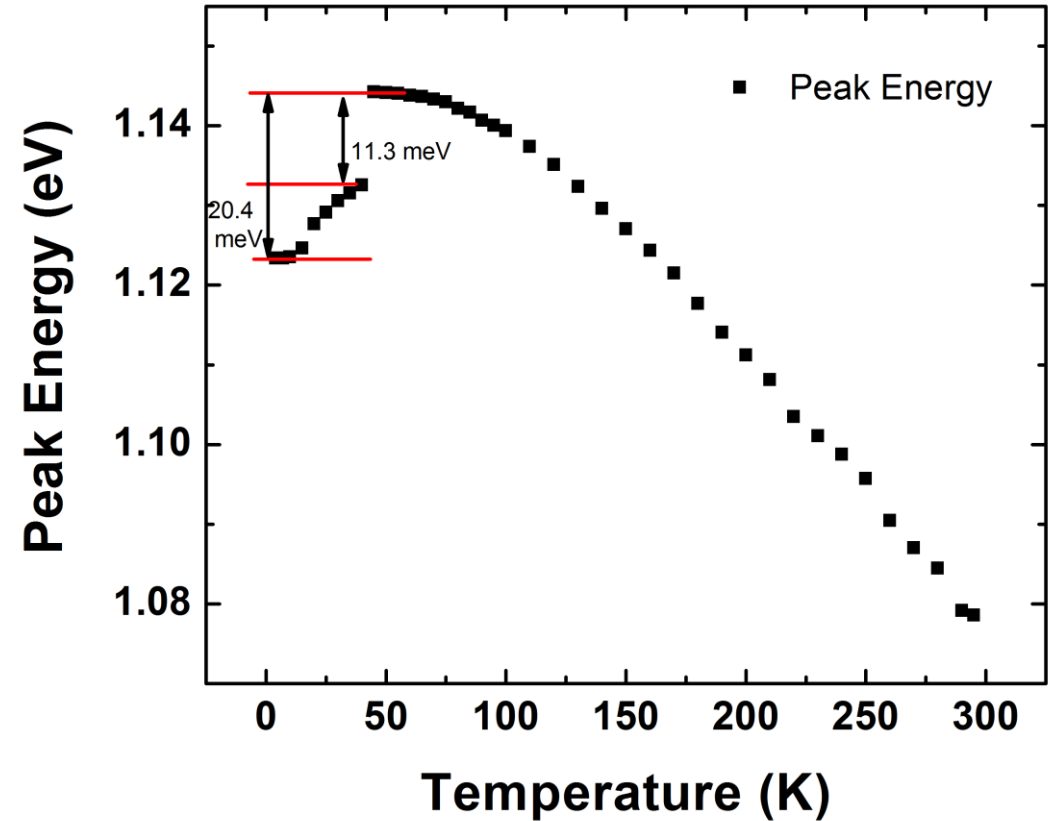
# Activation Energy Fit - Intrinsic

- ▶ 
$$\frac{I_0}{1+C_1e^{-E_1x/(8.617 * 10^{-5})}+C_2e^{-E_2x/(8.617*10^{-5})}}$$
- ▶ Two energy values were fitted, 3.48 meV and 13.87 meV
- ▶ 3.48 meV translates to ~40K



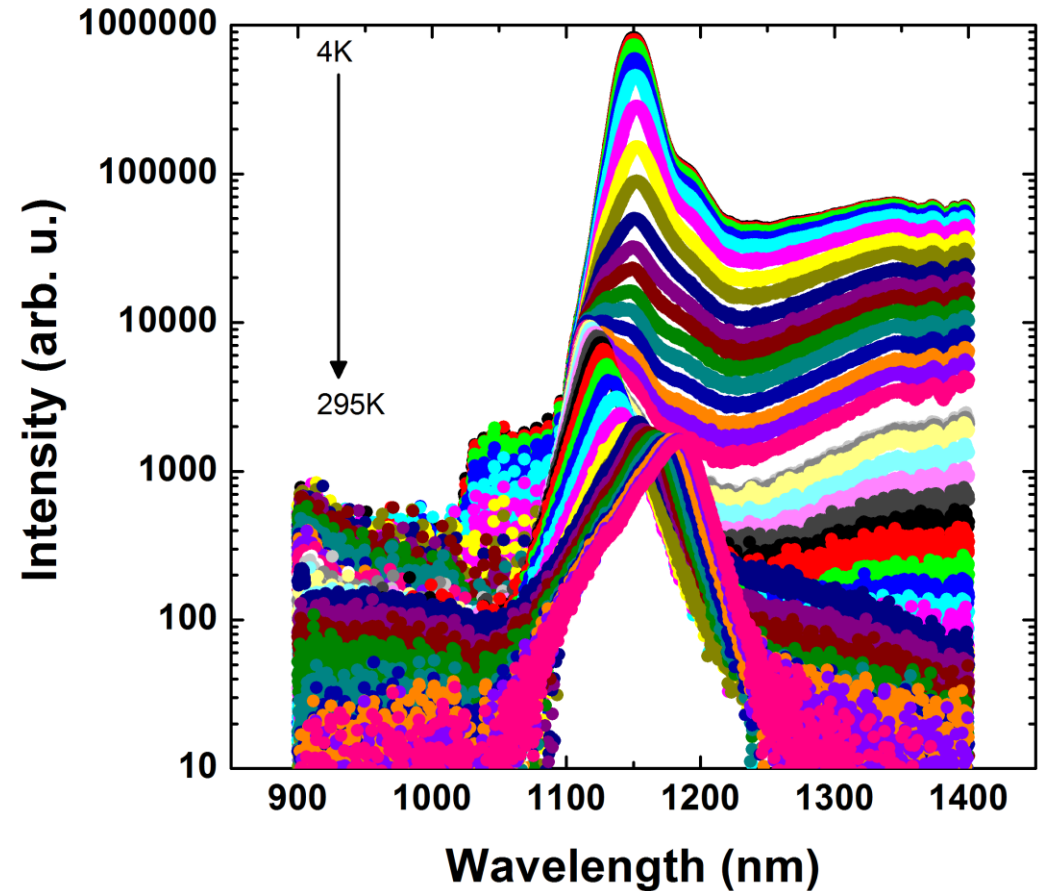
# Activation Energy Fit - Intrinsic

- ▶ 
$$\frac{I_0}{1+C_1e^{-E_1x/(8.617 * 10^{-5})}+C_2e^{-E_2x/(8.617*10^{-5})}}$$
- ▶ Two energy values were fitted, 3.48 meV and 13.87 meV
- ▶ 3.48 meV translates to ~40K
- ▶ 13.87 meV could reference the difference in energy of localized states and band gap



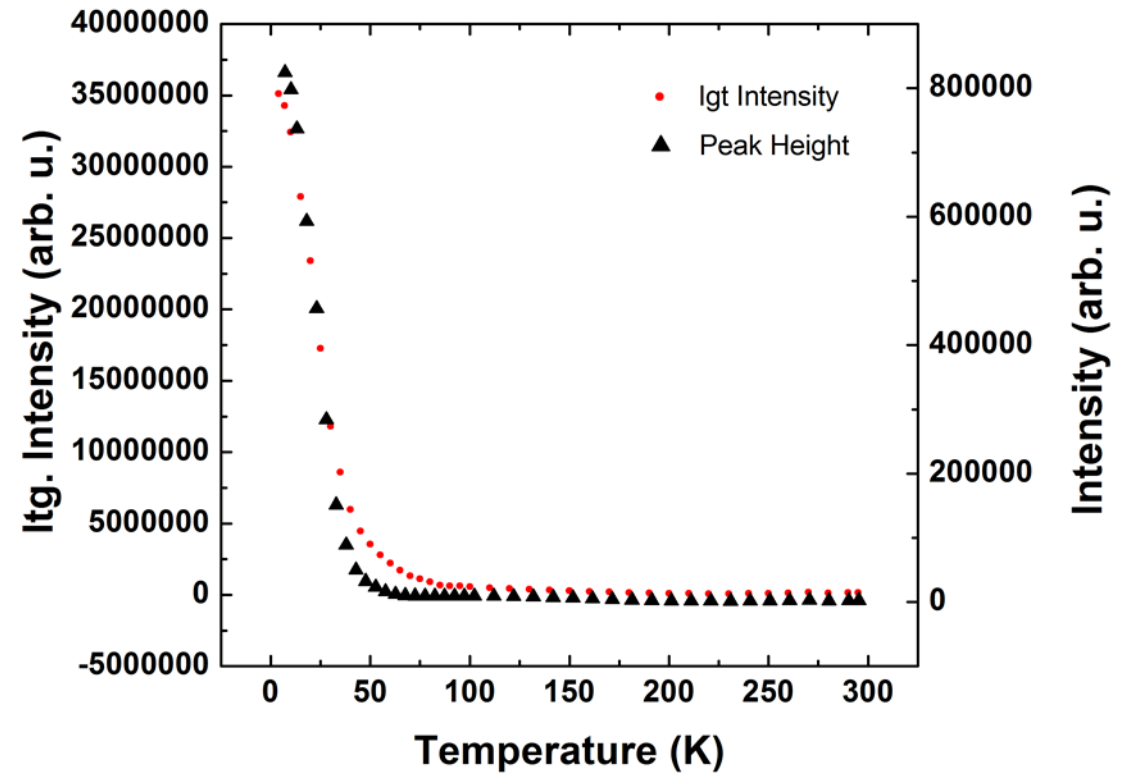
# N-type - PL

- ▶ Large defect band at low temperatures
- ▶ Carrier localization at low temperatures
- ▶ Peak dominance shifts at 70 K
- ▶ Shoulder-Peak energy difference, 22.9 meV



# N-type - PL

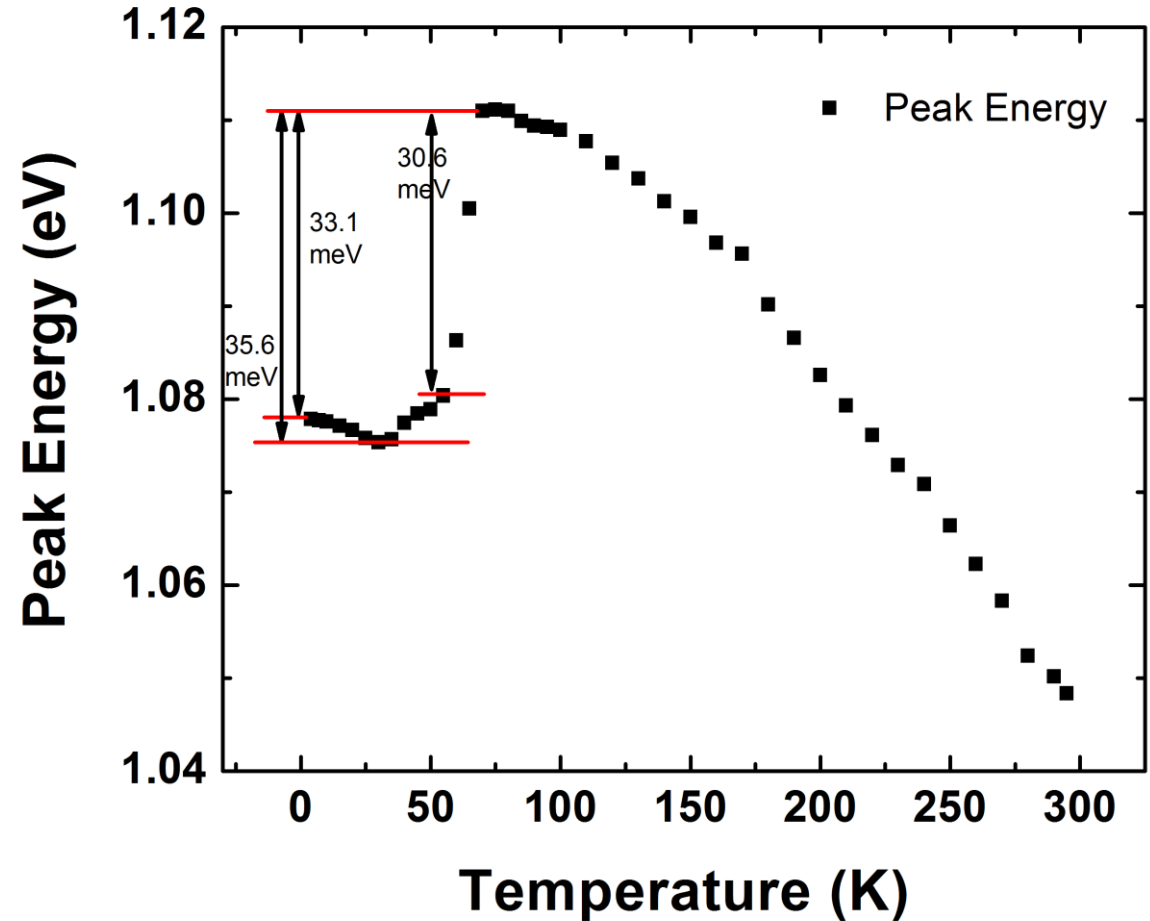
- ▶ Carrier localization at low temperatures
- ▶ Peak dominance shifts at 70 K
- ▶ Large quench in intensity reflects carrier diffusion





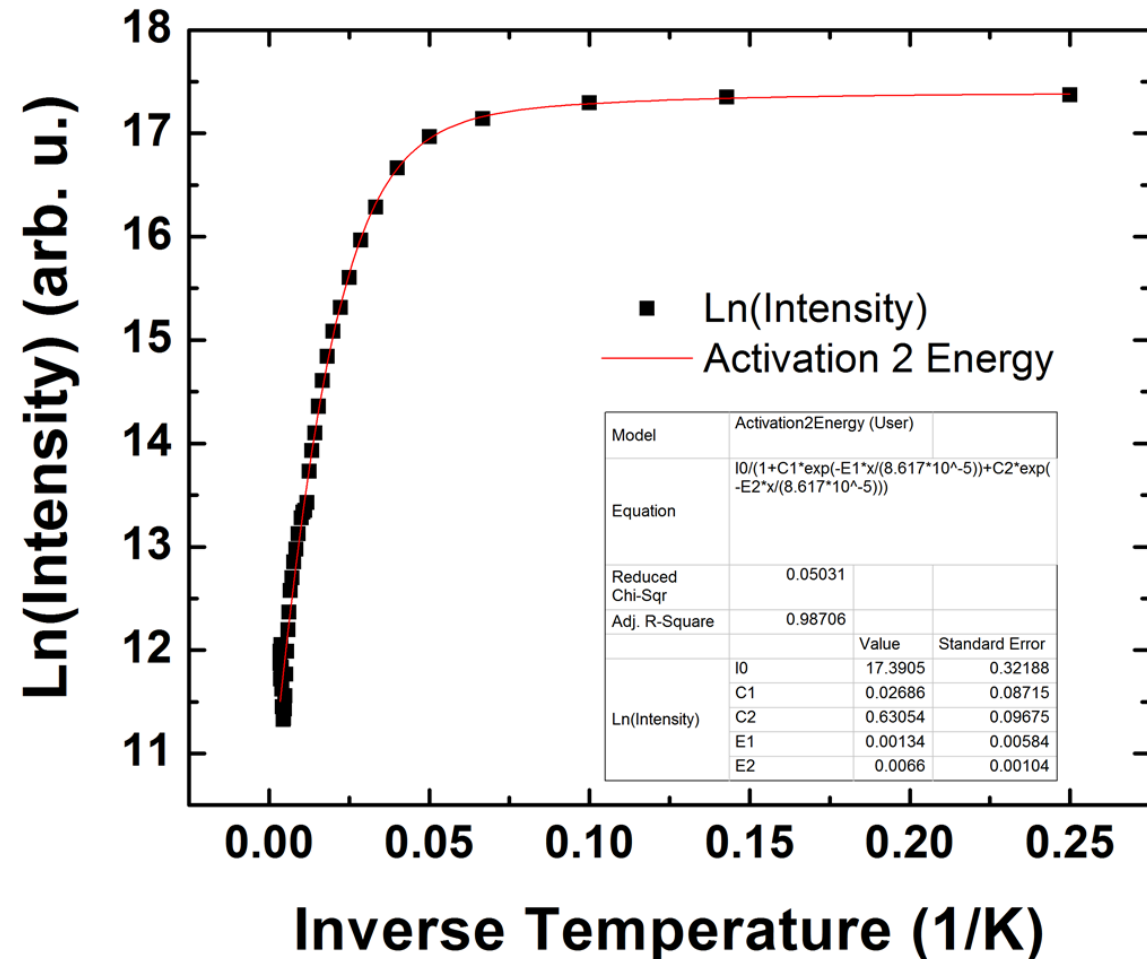
# N-type - Peak Energy

- ▶ Shows S-shaped dependence
- ▶ Reflects change in PL dominance at 70K
- ▶ Two processes occur



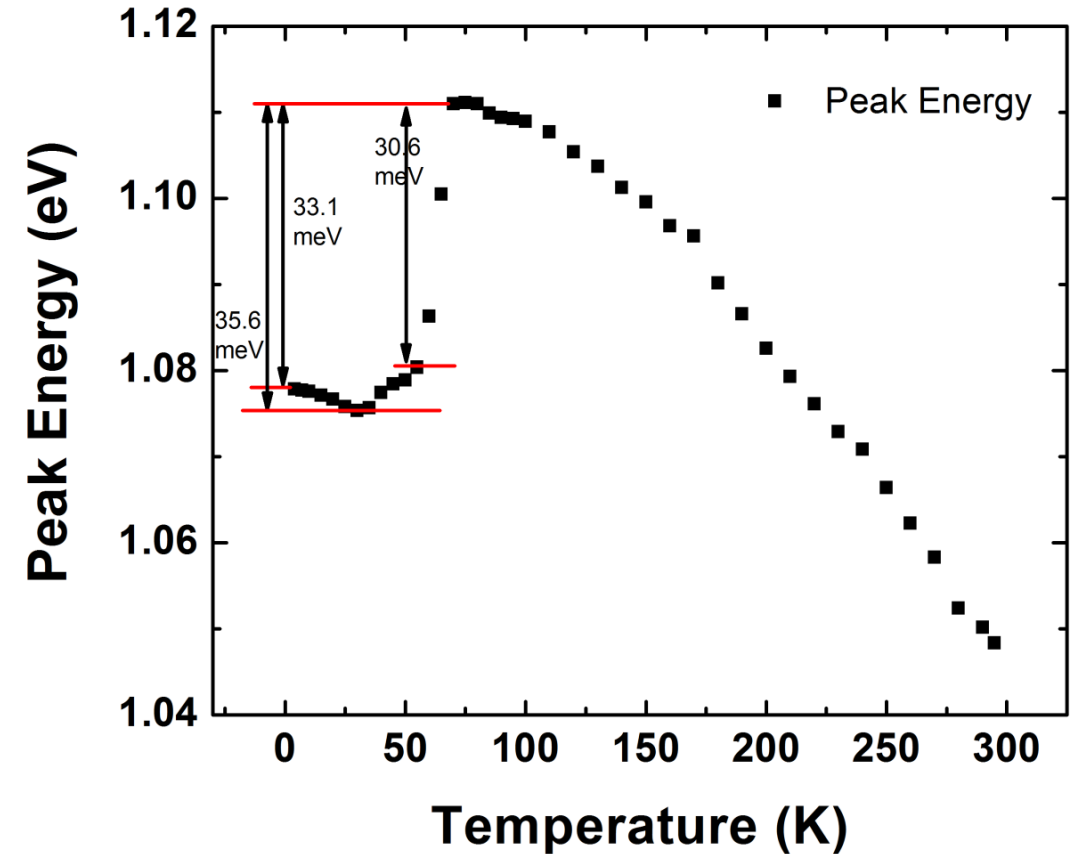
# Activation Energy Fit - n-type

- ▶ 
$$\frac{I_0}{1+C_1e^{-E_1x/(8.617 * 10^{-5})}+C_2e^{-E_2x/(8.617*10^{-5})}}$$
- ▶ Two energies fit, 1.34 meV and 6.6 meV
- ▶ 6.6 meV translates to ~76 K
- ▶ 1.34 meV translates to ~15 K



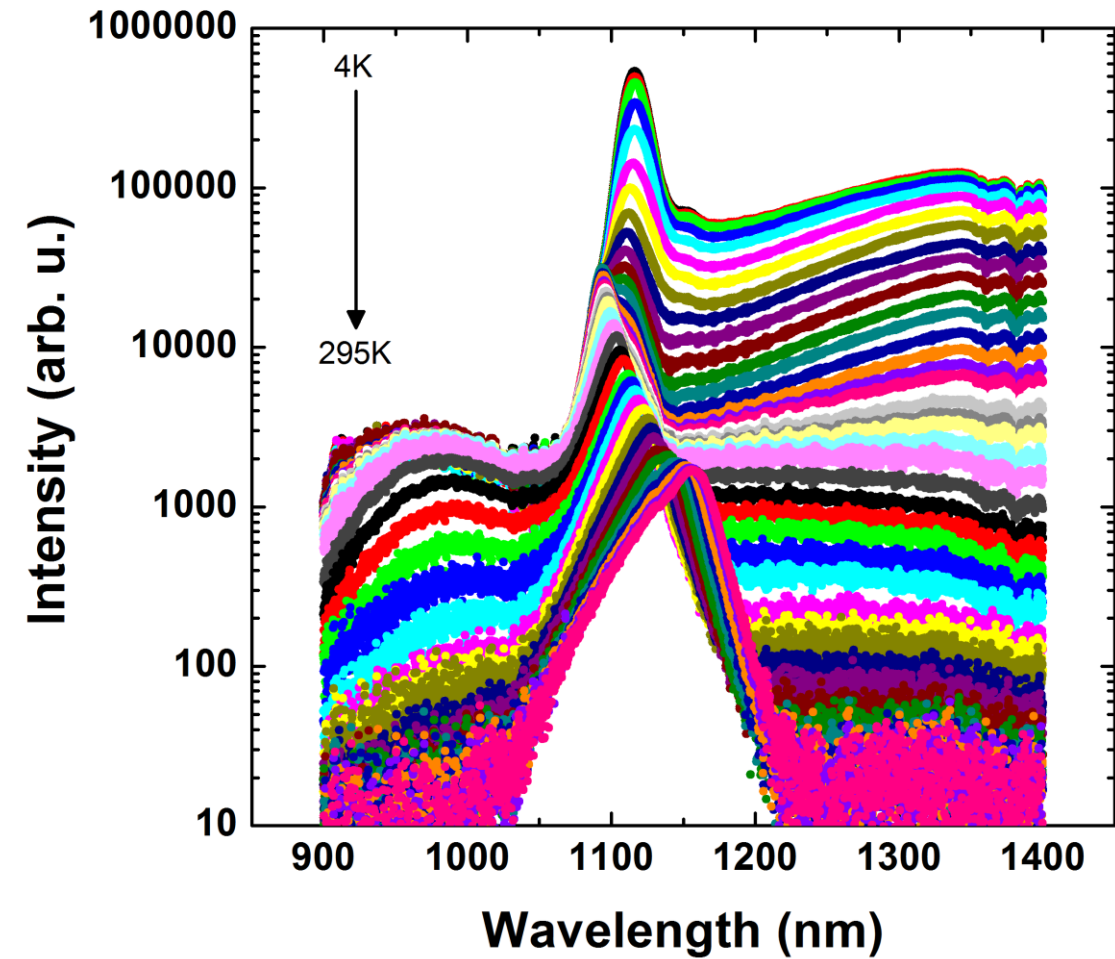
# Activation Energy Fit - n-type

- ▶ 
$$\frac{I_0}{1+C_1e^{-E_1x/(8.617 * 10^{-5})}+C_2e^{-E_2x/(8.617*10^{-5})}}$$
- ▶ Two energies fit, 1.34 meV and 6.6 meV
- ▶ 6.6 meV translates to ~76 K
  - ▶ Close to where the peak transition occurs
- ▶ 1.34 meV translates to ~15 K
  - ▶ Possibly first dip in Peak energy



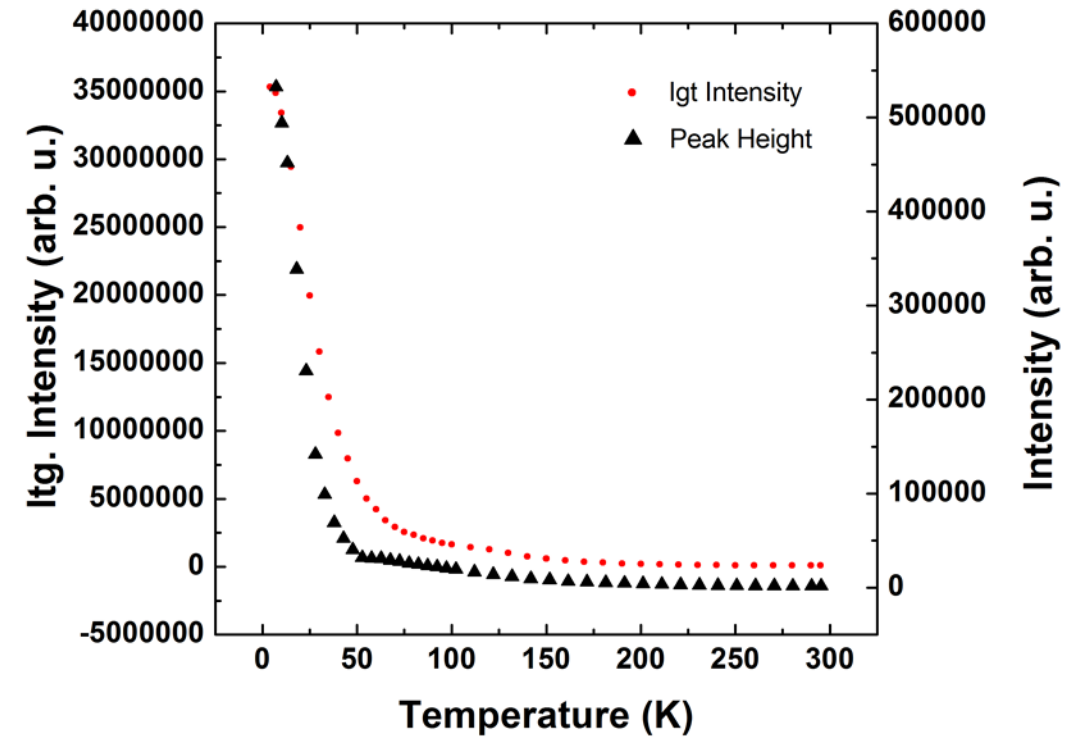
# P-type - PL

- ▶ Large defect band at low temperatures
- ▶ Carrier localization at low temperatures
- ▶ Peak dominance shifts at 50 K - 55 K
- ▶ Shoulder-Peak energy difference 18.11 meV



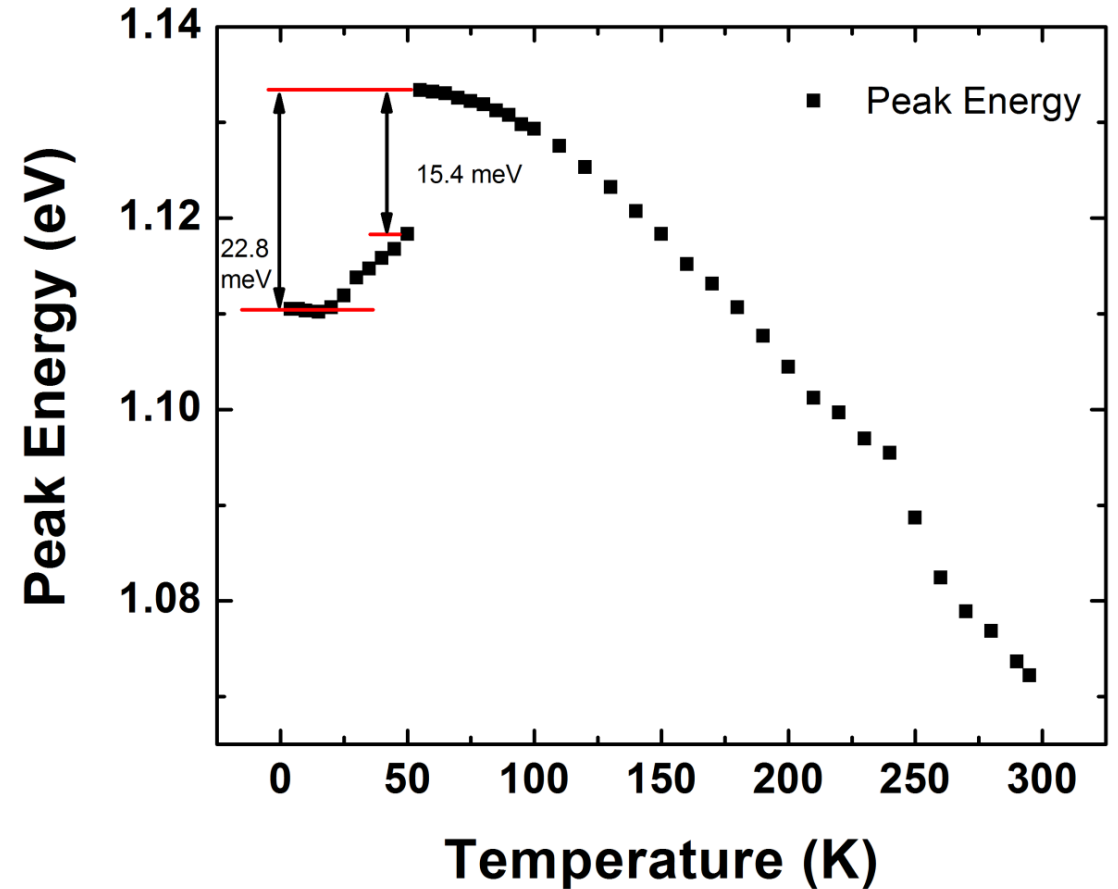
# P-type - PL

- ▶ Carrier localization at low temperatures
- ▶ Peak dominance shifts at 50 K - 55 K
- ▶ Large quench in intensity



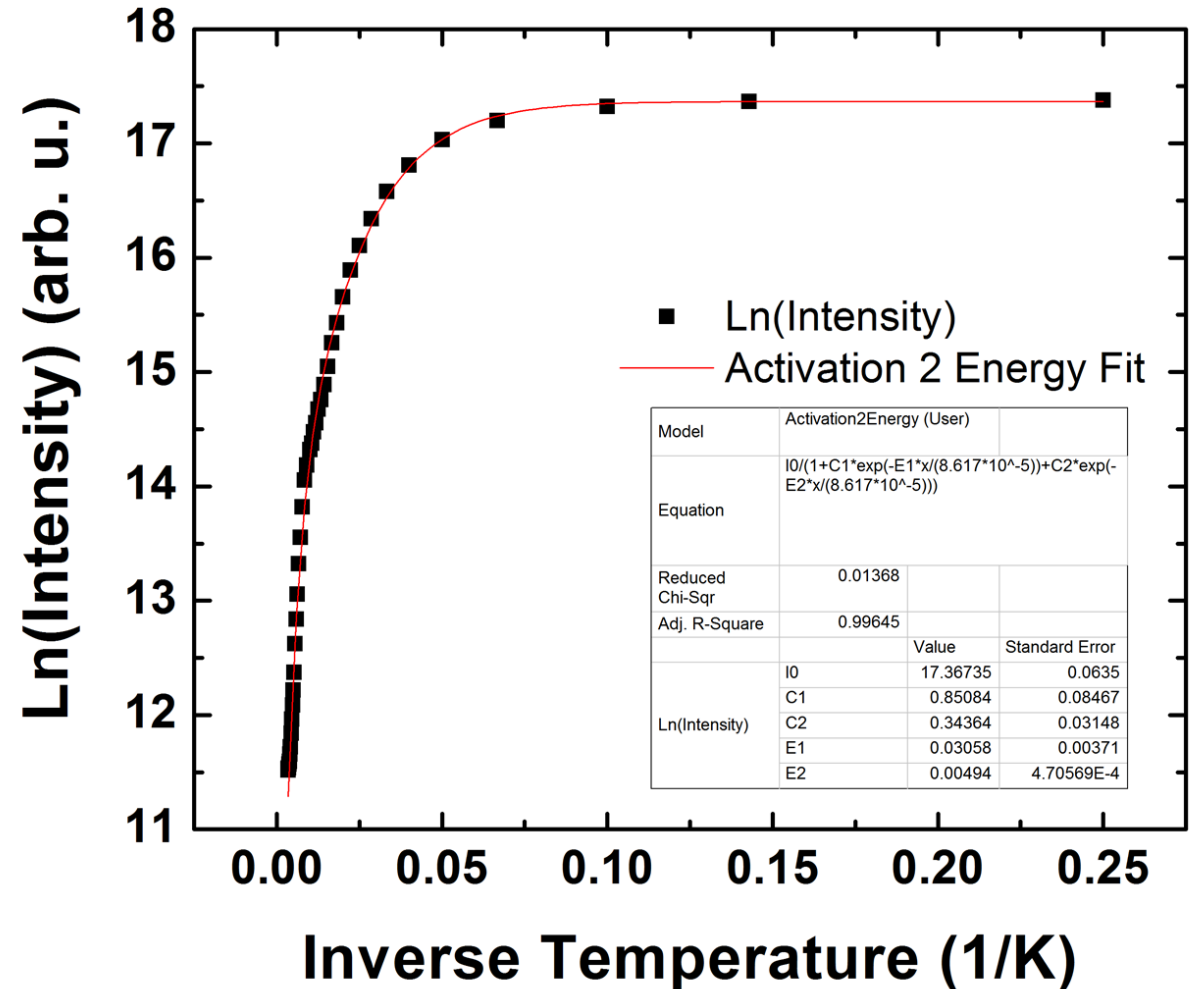
# P-type - Peak Energy

- ▶ S-shaped dependence as observed in previous samples
- ▶ Shift in peak energy reflects shift in peak dominance at 55K



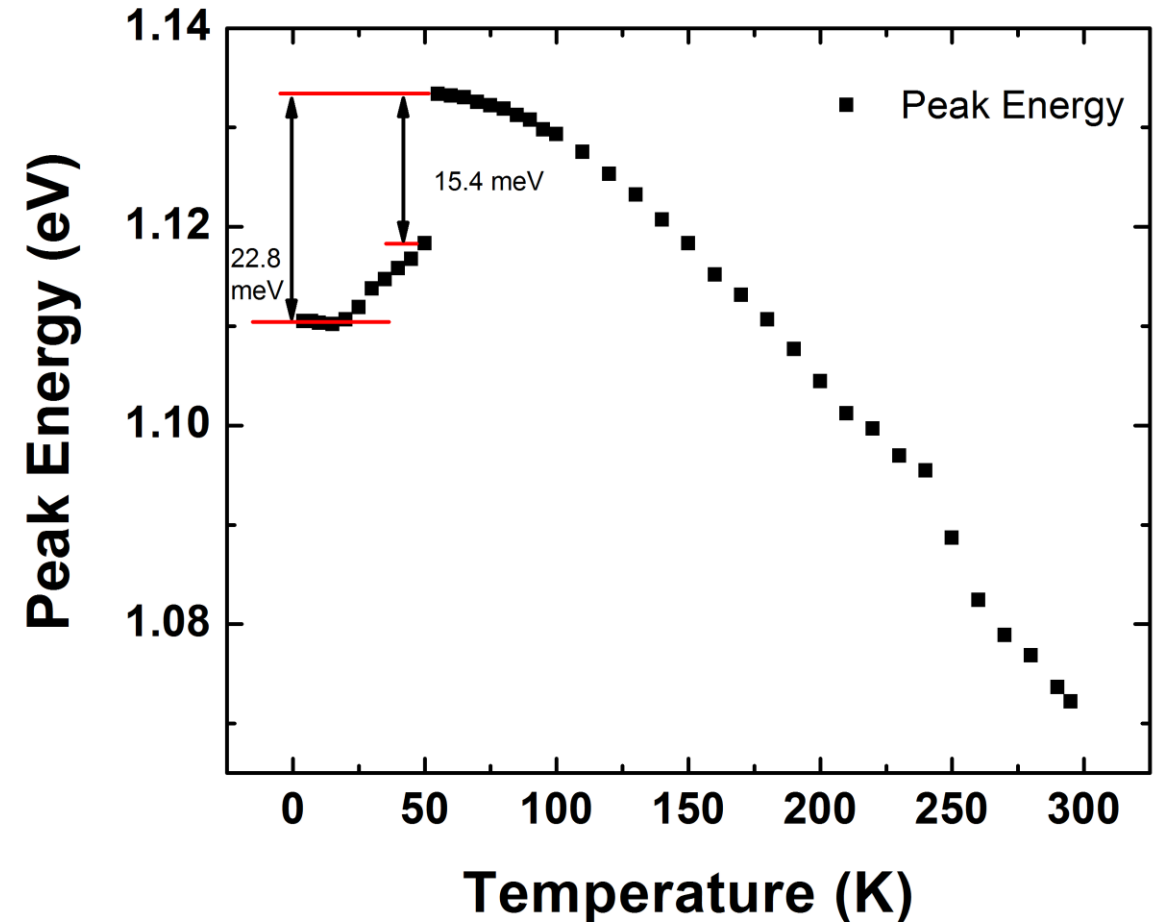
# Activation Energy Fit - p-type

- ▶ 
$$\frac{I_0}{1+C_1e^{-E_1x/(8.617 \cdot 10^{-5})}+C_2e^{-E_2x/(8.617 \cdot 10^{-5})}}$$
- ▶ Two energies fit, 30.58 meV and 4.94 meV
- ▶ 4.94 meV translates to ~57 K



# Activation Energy Fit - p-type

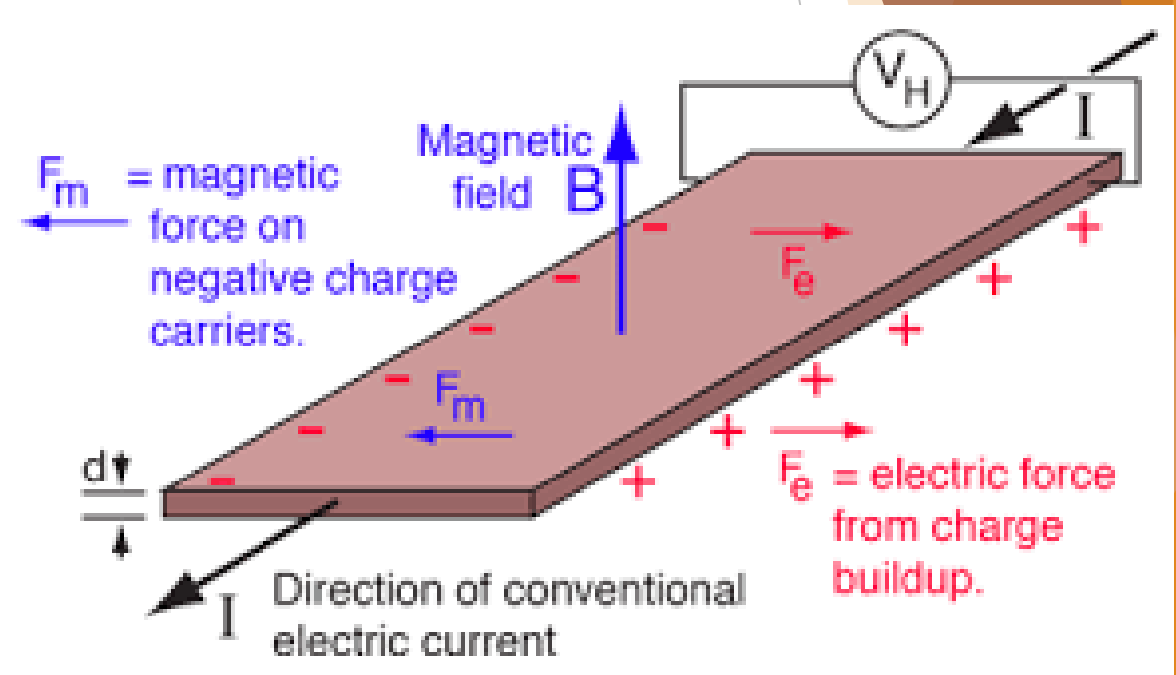
- ▶ 
$$\frac{I_0}{1+C_1e^{-E_1x/(8.617 * 10^{-5})}+C_2e^{-E_2x/(8.617*10^{-5})}}$$
- ▶ Two energies fit, 30.58 meV and 4.94 meV
- ▶ 4.94 meV translates to ~57 K
- ▶ Close to where peak energy transition occurs





# Experimental Techniques - Hall Effect

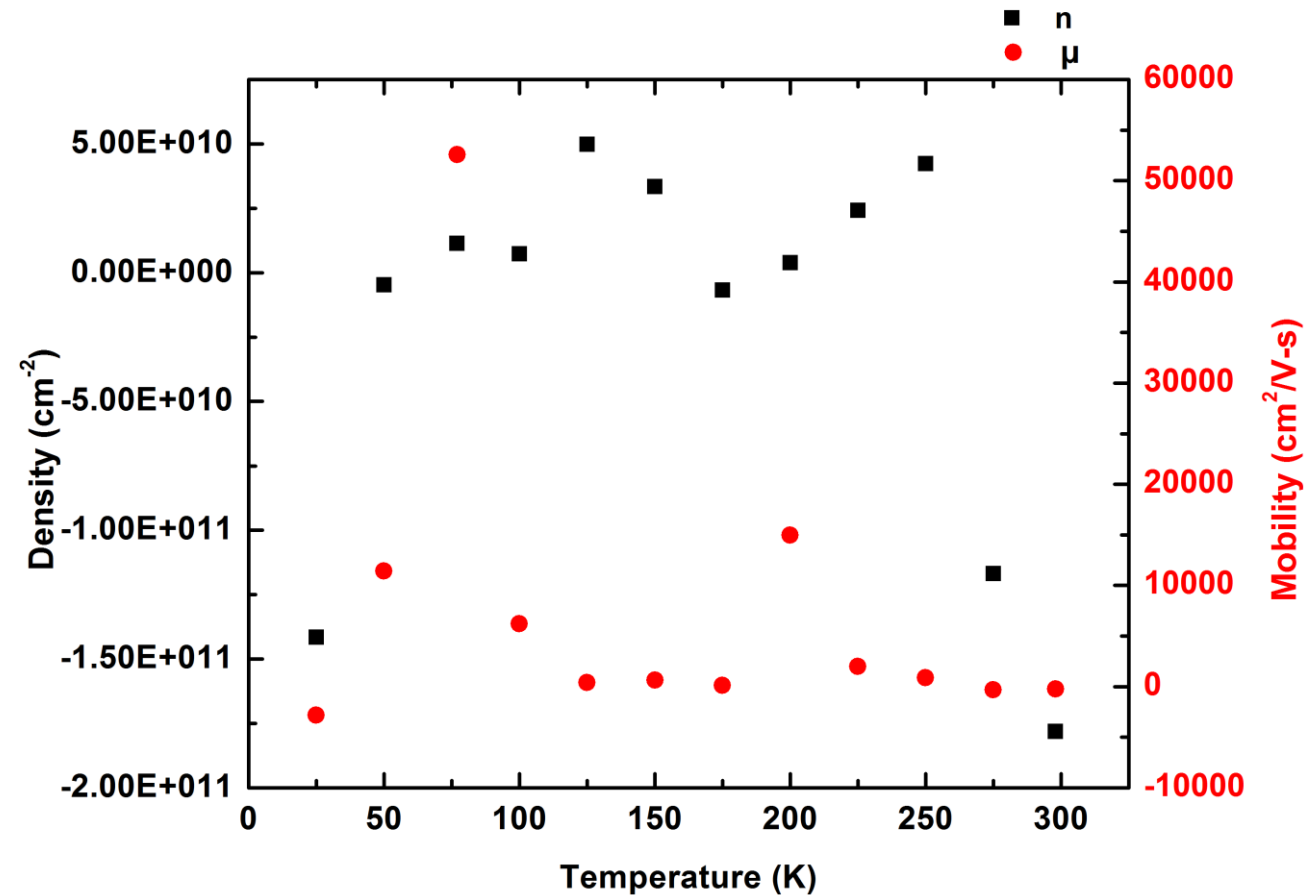
- ▶ Application of Lorentz Force
- ▶ Bends charge carriers in the semiconductor
- ▶ This then creates an electric field, in the transverse direction
- ▶ The electric field then produces the Hall Voltage



<http://hyperphysics.phy-astr.gsu.edu/hbase/magnetic/Hall.html>

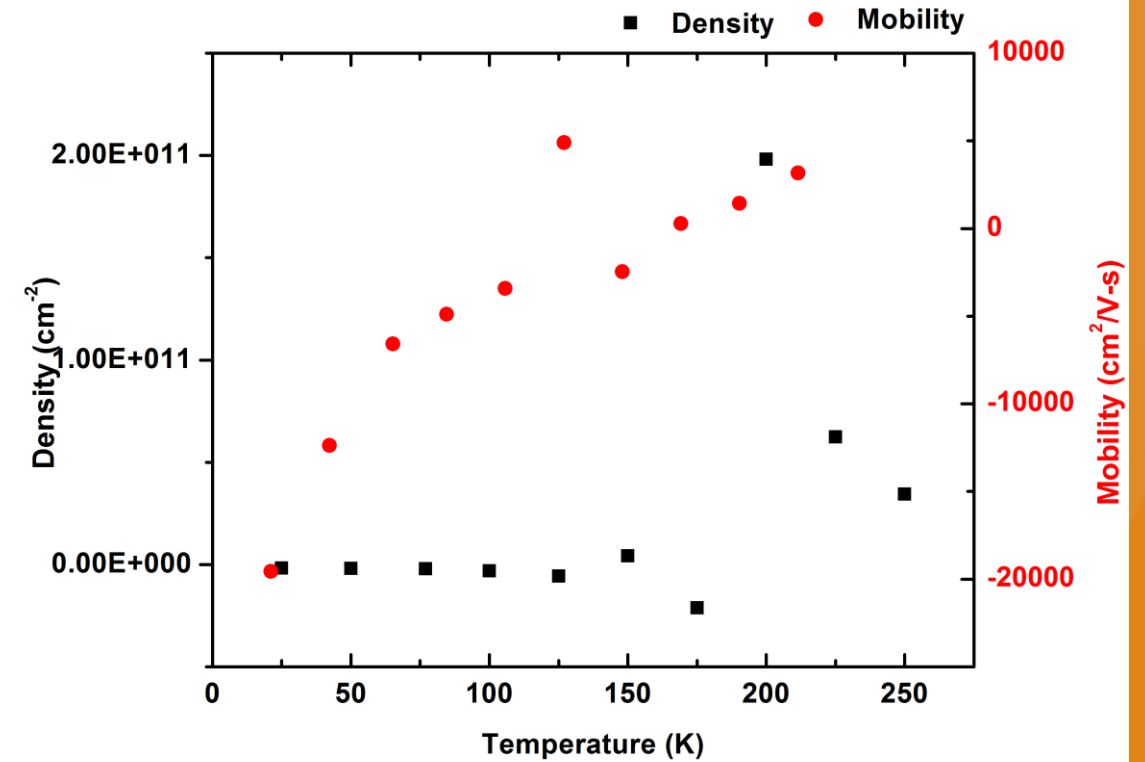
# Intrinsic - Hall

- ▶ Negative density indicates p-type, positive n-type
- ▶ Hall signal is very noisy
- ▶ Think we are only probing surface



# N-type - Hall

- ▶ Negative density indicates p-type, positive n-type
- ▶ Density appears to be zero due to large difference in order of magnitudes
- ▶ Hall signal is very noisy
- ▶ Think we are only probing surface



# Future Plans

- ▶ Etch cap off of samples and perform Hall measurements
- ▶ Perform PL and Hall measurements on hydrogenated samples
- ▶ Compare to find hydrogenation's effect on electrical properties